

Docket Number: 081468-0308989

Client Reference: P-1839.000-US



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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of VAN DER PASCH, et al.

Application No.: 10/813,682

Filed: March 31, 2004

For: LITHOGRAPHIC APPARATUS AND DEVICE MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

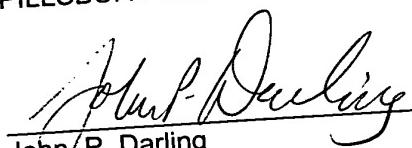
Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. A copy of the English translation of the foreign office action is included. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the references have been considered, per MPEP § 609.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

An English language translation of the Korean Office Action that indicates the degree of relevance found by the foreign office is attached, thereby satisfying the requirement for a concise explanation.

Respectfully Submitted,
PILLSBURY WINTHROP SHAW PITTMAN LLP


John P. Darling
Registration Number 44482
Customer Number: 00909

Date: September 26, 2006
Telephone: (703) 770-7900
Facsimile: (703) 770-7901
P.O. Box 10500
McLean, VA 22102

FORM PTO-1449 (modified)
 To: U.S. Department of Commerce
 (PW FORM PAT-1449)
 Patent and Trademark Office



**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Date: September 26, 2006

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Atty. Dkt. No.	M#	Client Ref.
	0308989	P-1839.000-US
Applicant: VAN DER PASCH et al.		
Appln. No.: 10/813,682		
Filing Date: March 31, 2004		
Examiner: Bernard E. Souw		Group Art Unit: 2881

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
AR	6,208,707 B1	03/27/2001	Oshino			
BR	2001/0026402 A1	10/04/2001	Gerhard et al.			
CR						
DR						
ER						
FR						
GR						
HR						
IR						
JR						
KR						
LR						
MR						
NR						

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
					Enclosed	No	Enclose	No
OR								
PR								
QR								
RR								
SR								
TR								
UR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

VR	Translation of Korean Office Action issued in Korean Application No. 10-2005-0026260 dated June 26, 2006			X
WR				
XR				
YR				
ZR				
AAR				

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.